



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

U.S. Serial No. 10/743,629

Applicant: Ki Min LEE

Filed: December 22, 2003

Title: "Methods of Preventing

### Oxidation of Barrier Metal of

## Semiconductor Devices"

TC/AU: 2818

Examiner: NHU, David

Docket No.: 20063/OG03-040

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO THE OFFICE ACTION DATED MARCH 3, 2005

Dear Sir:

Please enter the following amendments and consider the following remarks.

**Changes to the Specification** begin on page 2 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 3 of this paper.

**Remarks begin on page 5 of this paper.**